



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIBDATASHEET

Bib Data Sheet

CONFIRMATION NO. 6895

SERIAL NUMBER 10/665,483	FILING DATE 09/22/2003 RULE	CLASS 451	GROUP ART UNIT 3723	ATTORNEY DOCKET NO. 52775-025
-----------------------------	---------------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Masahiro Nakayama, Hyogo, JAPAN;

Naoki Matsumoto, Hyogo, JAPAN;

Koshi Tamamura, Tokyo, JAPAN; Masao Ikeda, Tokyo, JAPAN;

** CONTINUING DATA ***** None S.A.

** FOREIGN APPLICATIONS ***** Yes S.A.

JAPAN 128060/2003 05/06/2003

JAPAN 281647/2003 07/29/2003

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 12/12/2003

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <u>S.A.</u> Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 8	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 5
--	---	------------------------------	------------------------	-----------------------	----------------------------

ADDRESS

McDERMOTT, WILL & EMERY

600 13th Street, N.W.

Washington, DC

20005-3096

TITLE

Nitride semiconductor wafer and method of processing nitride semiconductor wafer

FILING FEE RECEIVED 918	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-----------------------------------	---	---